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List of Documents Filed by Applicant (Use several sheets if necessary)		Applicant: Peter J. McGuinness et al.	
		Filing Date: November 16, 2001	Group: 264/2623

U.S. PATENT DOCUMENTS							
Ex- In't	Document Number	Date	Name	Class	Sub- class	Filing Date, if applicable	

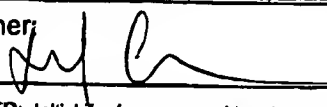
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Sub- class	Trans'n Yes/No	
✓	AA1	GB 2,272,285	May 11, 1994	UK			

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
✓	AA2	R. Deriche et al., "Robust Recovery of the Epipolar Geometry for an Uncalibrated Stereo Rig", Proceedings of the European Conference on Computer Vision, pages 567-576, Stockholm, Sweden, May 1994, Springer-Verlag, SNCS 800.
✓	AA3	Z. Zhang et al., "A Robust Technique for Matching Two Uncalibrated Images Through the Recovery of the Unknown Epipolar Geometry", Artificial Intelligence Journal Vol. 78, pages 87-119, October 1995
✓	AA4	T. Kanade, "A Stereo Machine for Video-Rate Dense Depth Mapping and Its new Applications, School of Computer Science, Carnegie Mellon University, IEEE Conf. Computer Vision and Pattern Recognition, 1996.
✓	AA5	P.H.S. Torr et al., "Robust Parameterization and Computation of the Trifocal Tensor", Image and Vision Computing, 1997.
✓	AA6	M. Pollefeys et al., "Self-Calibration and Metric Reconstruction in spite of Varying and Unknown Internal Camera Parameters, IEEE International Conf. Computer Vision, 1998
✓	AA7	K. Ng, "3D Visual Modeling and Virtual View Synthesis: A Synergetic, Range-Space Stereo Approach Using Omni-Directional Images," Ph.D. Dissertation, University of California, San Diego, March 2000
✓	AA8	Kim C. Ng et al., "Range-Space Approach for Generalized Multiple Baseline Stereo and Direct Virtual View Synthesis", IEEE Workshop on Stereo and Multiple-Baseline Vision, December 9-10, 2001
✓	AA9	George Q. Chen, "Robust Point Feature Matching In Projective Space", IEEE Computer Vision and Pattern Recognition 2001.

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